

Sheet 1 of 2

Form PTO-1449 (REV. 8-83)	US Dept. of Commerce PATENT & TRADEMARK OFFICE	ATTY DOCKET NO. 105024.02	New 53(b) Divisional Application of U.S. Patent Application No. 09/630,444
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		APPLICANT(S) Sadao KANBE et al.	
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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	3,554,125	1/1971	VAN DORN et al.		
	3,673,961	7/1972	JARVIS		
	4,729,310	3/1988	LOVE, III		
	4,833,486	5/1989	ZERILLO		
	4,836,105	6/1989	HOEKSTRA et al.		
	4,879,176	11/07/1989	Andrew OUDERKIRK et al.		
	5,059,513	10/1991	HOPF et al.		
	5,145,758	9/1992	KOSSMEHL et al.		
	5,254,429	10/1993	GRACIA et al.		
	5,272,979	12/1993	LEWIS et al.		
	5,468,597	11/1995	CALABRESE et al.		
	6,336,697	01/2002	FUKUSHIMA		

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
EP 0 351 793 A2	01/24/1990	Europe		
EP 0 769 331 A1	04/23/1997	Europe		
DE 35 35 696 A1	10/05/1985	Germany		
WO 95/21030 A1	08/10/1995	PCT		
EP 0 794 015 A1	09/10/1997	Europe		
WO 97/38802 A1	10/23/1997	PCT		
WO 98/40169 A1	09/17/1998	PCT		
59-075205 (with English-language Abstract)	04/27/1984	Japan		
GB 850 934 A	10/1960	Great Britain		
FR 701 903 A	03/1931	France		
JP-45-24075	09/1970	Japan		
JP-B2-57-4116	01/1982	Japan		
JP-A-7-245467	09/1995	Japan		

Date: March 10, 2004

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /WPF/

	JP-A-5-202483	08/1993	Japan		
	JP-A-63-33895	02/1998	Japan		
	JP-51-43769	11/1976	Japan		
	JP-A-58-222592	12/1983	Japan		
	JP-B2-3-22467	03/1991	Japan		
	JP-A-7-166372	06/1995	Japan		
	JP-51-106638	09/1976	Japan		
	JP-A-64-5095	01/1989	Japan		
	JP-52-40886	10/1977	Japan		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	Greg GILLEN, et al.; <u>Patterning of Self-Assembled Alkanethiol Monolayers on Silver by Microfocus Ion and Electron Beam Bombardment</u> ; 320 Appl. Phys. Lett.; 65(5) pgs. 534-536 (1994).
	<u>Fabrication of Gold Nanostructures by Lithography with Self-Assembled Monolayers</u> , IBM Technical Disclosure Bulletin, Vol. 39, No. 12; December 1996; pgs. 235-238.
	Drake, J. "Chemical Technology in printing and imaging systems", 1993, ROYAL SOCIETY OF CHEMISTRY, Cambridge XP002189010, pages 33-35, and pages 58-59.

EXAMINER

/William Phillip Fletcher III/

DATE CONSIDERED
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Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.